I hereby certify that this correspondence is being deposited with the United States Postal Service as First Class Mail in an envelope addressed to:

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Kareh Cing-Mars

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Re Application of :

May 18, 2004

Lavin et al.

Serial No. 10/707,778

Examiner:

Filed: 01-12-04

IBM Corporation

Dept. 18G/Bldg. 300-482

Title: SYSTEM AND METHOD OF SMOOTHING MASK SHAPES FOR IMPROVED PLACEMENT OF SUB-RESOLUTION ASSIST FEATURES :

2070 Route 52 Hopewell Junction New York 12533-6531

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents P. O. Box 1450 Alexandria, VA 22313-1450

Sir:

In compliance with the duty of disclosure under 37 C.F.R. § 1.56 and in accordance with the practice under 37 C.F.R. §§ 1.97 and 1.98, the Examiner's attention is directed to the documents listed on the enclosed Form PTO-1449. Copies of the listed documents are also enclosed, excluding US patents.

It is respectfully requested that the above information be considered by the Examiner and that a copy of the enclosed Form PTO-1449 be returned indicating that such information has been considered.

Applicants undersigned attorney may be reached by telephone

FIS920030323US1

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at (845) 894-6919. All correspondence should continue to be directed to the below listed address.

Respectfully submitted,

Todd M. C. Li

Attorney for Applicants Registration No.45,554

INTERNATIONAL BUSINESS MACHINES CORPORATION Intellectual Property Law Department B/300-482 2070 Route 52 Hopewell Junction, New York 12533 Facsimile: (845) 892-6363

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FORM PTO-			ATTY. DOCKET NO.	SERIAL NO.						
LIST OF PAT	TENTS /	AND PUBLICATIONS FOR APPLICABIT'S CLOSURE STATEMENT	FIS920030323US1	10/707,778						
INFORMATI	ON DIO	P. FAT. TO SEE	APPLICANT: LAVIN ET AL.							
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REFEREN	CE DE	SIGNATION OTHER ART								
ОТ	HER A	ART (Including Author, Title, Date,	Pertinent Pages, etc.)	*						
EXAMINER INITIALS										
	AJ	Granik et al., "Two-dimensional G-MEEF Theory and Applications," Proceedings of SPIE - The International Society for Optical Engineering v.4754 2002 p.146-155.								
	Al	LaCour et al., "Model-Based OPC For Sub-Resolution Assist Feature Enhanced Layouts," Proceedings of SPIE - The International Society for Optical Engineering, 2002.								
	AK	Joesten et al., "The Effect Of Scattering Bar Assist Features In 193 Nm Lithography," Optical Microlithography XV. Proceedings of SPIE - The International Society for Optical Engineering v.4691 II 2002 p.861-870.								
	AL	Shi et al., "Understanding The Forbidden Pitch Phenomenon And Assist Feature Placement," Metrology, Inspection, and Process Control for Microlithography XVI. Proceedings of SPIE - The International Society for Optical Engineering v.4689 II 2002 p.985-996.								
	AM	Reblinksy et al., "Lithographic Comparison Of Assist Feature Design Strategies," Optical Microlithography XV Santa Clara, CA, USA 5-8 March 2002.								
	AN	Smith, "Mutually Optimizing Resolution Enhancement Techniques: Illumination, APSM, Assist Feature OPC, And Gray Bars," Optical Microlithography XIV. Proceedings of SPIE - The International Society for Optical Engineering v.4346 n.1 2001 p.471-485.								
	AO	Liebman et al., "Optimizing Styl	yle Options For Sub-Resolution Assist Features" Optical lings of SPIE - The International Society for Optical							
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EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

EXAMINER

				ATTY DOCKET NO. FIS92003032		SERIAL NO. 10/707,778				
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		OTHER DOCK	MENTS (Including (Luthor Title Date Parting	ant Pages Etc		<u> </u>			
		Chen et al., "Templa		Author, Title, Date, Pertine Assist Feature Script Implem 2 p.156-166			- The Inter	national		
		Society for Optical E	ngineering, v.4754 2002	z p.150-100						
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Form PTO-A820 (also form PTO-1449)